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Canadian Patents Database

Search Results

11/10/2004 - 13:45:47

Query :

Query: ((piezoelectric <or> component) <and> silicone <near> (conductive <or> conducting <or> conductive) <near> (adhered <or> adhering <or> adhesive) <and> electrode)

7 documents out of 1613210 matched your query. Click on its number to view the details of the document.

Note: All document detail pages now appear on a new Browser Window.

1. [2151510](#) METHOD OF MOUNTING A PIEZOELECTRIC ELEMENT TO A SUBSTRATE 84%
2. [2451789](#) ASSAY PLATES READER SYSTEMS AND METHODS FOR LUMINESCENCE TEST MEASUREMENTS 68%
3. [2378190](#) MICROFABRICATED ELASTOMERIC VALVE AND PUMP SYSTEMS 63%
4. [1153794](#) TRANSCUTANEOUS CARBON DIOXIDE MEASURING SENSOR 55%
5. [2443782](#) PROCESS FOR MANUFACTURING ELECTRICALLY CONDUCTIVE COMPONENTS 21%
6. [2291280](#) USE OF A CARBOSILOXANE DENDRIMER IN ELECTROPHOTOGRAPHIC TECHNOLOGIES, ELECTROSTATIC RECORDING TECHNOLOGIES, AND ELECTROSTATIC PRINTING TECHNOLOGIES 10%
7. [2316196](#) IONTOPHORESIS DEVICE AND DRUG UNIT 08%

Searching PCT (Full Text)...

[Search Summary]

Results of searching in PCT (Full Text) for:

(Piezoelectric or component) and silicone near (conductive or conducting or conductive) near (adhered or adhering or adhesive) and electrode: 7 records

Showing records 1 to 7 of 7 :

(Piezoelectric or component) and silicone near (cond

Title

1. [\(WO 2004/045027\) ANISOTROPIC CONDUCTIVE ADHESIVE AND FILM](#)
2. [\(WO 03/096889\) CORRECTION OF BAROMETRIC PRESSURE BASED ON REMOTE SOURCES OF INFORMATION](#)
3. [\(WO 02/102911\) METHOD FOR ADHERING SUBSTRATES USING ULTRAVIOLET ACTIVATABLE ADHESIVE FILM AND AN ULTRAVIOLET IRRADIATION APPARATUS](#)
4. [\(WO 02/097002\) ULTRAVIOLET ACTIVATABLE ADHESIVE FILM](#)
5. [\(WO 02/061010\) METHOD FOR ADHERING SUBSTRATES USING LIGHT ACTIVATABLE ADHESIVE FILM](#)
6. [\(WO 99/18756\) IMMERSIBLE PTC HEATING DEVICE](#)
7. [\(WO 99/06496\) ADHESIVE COMPOSITION FOR ELECTRICAL PTC HEATING DEVICE](#)

Search Summary

Piezoelectric NEAR conductive: 1690 occurrences in 463 records.

Piezoelectric NEAR adhered: 82 occurrences in 54 records.

(Piezoelectric NEAR conductive AND Piezoelectric NEAR adhered): 17 records.

component NEAR conductive: 8102 occurrences in 2213 records.

component NEAR adhered: 831 occurrences in 400 records.

(component NEAR conductive AND component NEAR adhered): 29 records.

((Piezoelectric NEAR conductive AND Piezoelectric NEAR adhered) OR (component NEAR conductive AND component NEAR adhered)): 46 records.

silicone NEAR conductive: 1511 occurrences in 543 records.

silicone NEAR adhered: 260 occurrences in 158 records.

(silicone NEAR conductive AND silicone NEAR adhered): 4 records.

((Piezoelectric NEAR conductive AND Piezoelectric NEAR adhered) OR

(component NEAR conductive AND component NEAR adhered)) AND (silicone NEAR conductive AND silicone NEAR adhered)): 0 records.

Piezoelectric NEAR conducting: 318 occurrences in 132 records.

Piezoelectric NEAR adhered: 82 occurrences in 54 records.

(Piezoelectric NEAR conducting AND Piezoelectric NEAR adhered): 2 records.

component NEAR conducting: 2058 occurrences in 914 records.

component NEAR adhered: 831 occurrences in 400 records.

(component NEAR conducting AND component NEAR adhered): 8 records.

((Piezoelectric NEAR conducting AND Piezoelectric NEAR adhered) OR (component

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	BRS	L1	13	piezoelectric and silicone adj3 conduct\$3 adj3 adhe\$4 and electrode\$1	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT; IBM_T DB	2004/11/1 0 13:37	
2	BRS	L2	10	component same mount\$3 and silicone adj3 conduct\$3 adj3 adhe\$4 and electrode\$1	US- PGPUB ; USPAT ; USOCR ; EPO; JPO; DERWE NT; IBM_T DB	2004/11/1 0 13:38	

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AND

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AND

Date of publication of application -- e.g.19980401 - 19980405 -

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